

Docket No.: Z&PINFP08190



04CD 07-27-01
#2/IPS
[Signature]
11/13/01

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231, on the date indicated below.

By: [Signature]

Date: 8/16/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Giuseppe Curello et al.
Applic. No. : 09/904,360
Filed : July 12, 2001
Title : Process for Producing a Doped Semiconductor Substrate

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,843,829 (Kuramae et al.), dated December 1, 1998;

United States Patent No. 6,048,781 (Turner et al.), dated April 11, 2000;

European Patent Application EP 0 889 502 A2 (Cardone et al.), dated January 7, 1999.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications,

patents and/or publications, it is because no existing translation is readily available to the applicant.

Respectfully submitted,



For Applicants

Mark P. Weichselbaum
Reg. No. 43,248

Date: August 16, 2001

Lerner And Greenberg, P.A.
Post Office Box 2480
Hollywood, FL 33022-2480
Tel: (954) 925-1100
Fax: (954) 925-1101

/bmb